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NIT-379

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

K. NAKAHARA et al.

Serial No. 10/606,834

Group Art Unit: 2826

Filed: June 27, 2003

Examiner: T. Dickey

For: DISTRIBUTED FEEDBACK SEMICONDUCTOR  
LASER EQUIPMENT EMPLOYING A  
GRATING (AS AMENDED)

REPLY

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22314

April 4, 2005

Sir:

In reply to the Office Action dated November 3, 2004,  
please amend the above-identified application as follows.  
A Petition for a Two-Month Extension of Time accompanies  
this Reply.

04/06/2005 MBEYENE1 00000118 10606834

01 FC:1202	100.00 OP
02 FC:1201	200.00 OP